

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## In re Application of:

Luo et al.

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING
PROTECTIVE LAYERS ON
SEMICONDUCTOR DEVICE
COMPONENTS SO AS TO REDUCE OR
ELIMINATE THE OCCURENCE OF
DELAMINATION THEREOF AND
CRACKING THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US

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## AMENDMNET UNDER 37 C.F.R. § 1.116

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Sir:

This Amendment follows the final Office Action of January 23, 2007, and the Advisory Action of March 6, 2007, the shortened statutory period for response to which expires on April 23, 2007.

A listing of claims, in which revisions to the claims are presented, begins on page 2 of this paper; and

Remarks start at page 7 of this paper.